TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))				Docket No. SEC.1101			
In Re Application Of: Ki-Hwan PARK et al.							
Se	erial No.	Filing Date	Examiner		Group Art Unit		
N	<b>IEW</b>	OCTOBER 30, 2003	TO BE ASSIGNED		TO BE ASSIGNED		
Title: METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFERS							
Address to:  Commissioner for Patents  P.O. Box 1450  Alexandria, VA 22313-1450							
	•	37 C	FR 1.97(b)				
ot th a <sub>l</sub>	1.   The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.						
		37 C	FR 1.97(c)				
C F	The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:						
	☐ the staten	nent specified in 37 CFR 1.97(e);	;				
OR							
	☐ the fee se	et forth in 37 CFR 1.17(p).					

<b>}</b>	OSURE STATEMENT 7(c))	Docket No. SEC.1101				
In Re Application: Ki-Hwan PARK et al.						
Serial No.	Filing Date	Examiner	Group Art Unit			
NEW	OCTOBER 30, 2003	TO BE ASSIGNED	TO BE ASSIGNED			
METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFERS .						
Payment of Fee  (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))						
as described belo Charge th Credit an Charge a Certificate of	he amount of ny overpayment. any additional fee required.  Transmission by Facsimile*  ment and authorization to charge deposit imile transmitted to the United States	Certificate of Mailing b  I certify that this document and on with as first class mail under addressed to the Commission.	Certificate of Mailing by First Class Mail  certify that this document and fee is being deposited n with the U.S. Postal Service s first class mail under 37 C.F.R. 1.8 and is ddressed to the Commissioner for Patents, P.O. Box 450, Alexandria, VA 22313-1450.			
	Signature	Signature of Person M	Signature of Person Mailing Correspondence			
Typed or Printed ?	Name of Person Signing Certificate	Typed or Printed Name of Per	son Mailing Certificate			
	ay only be used if paying by	Dated: OCTOBER 30, 2003				
VOLENTINE FRANCOS 12200 SUNRISE VALLEY RESTON VA 20191	•					
TEL. (703) 715-0870						
CC:						

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## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number			
SEC.1101	NEW			
Applicant(s) Ki-Hwan Park et al.				
Filing Date	Group Art Unit			
OCTODED 20 2002	TO DE ACCIONDO			

				Filing Date  OCTOBER 30, 2003  Group Art Unit  TO BE ASSIGNE			Z <b>D</b>		
				U.S. PAT	ENT DOCUMENTS				
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING IF APPRO	
	A	6,394,110	05/28/2002	KAMIK	AWA et al.				
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				FOREIG	N PATENT DOCUMENT	rs			
	REF	DOCUMENT NUMBER	DATE	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
								IES	NO
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				OTHER I	OOCUMENTS (Includ	ling Author, Title, I	Date, Pertinent Pag	zes, Etc.)	
				-					· -
EXAMINE	R				DATE CONSIDERED				
EXAMINE	R: Initi	al if citation considered, whether	or not citation is in	conformanc	e with MPEP Section 609	); Draw line throug	gh citation if not in	a conformar	ce and not

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considered. Include copy of this form with next communication to applicant.

P09A/REV04

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